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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	ATTORNEY DOCKET NO. CONFIRMATION NO	
10/603,389	06/25/2003	Sethuraman Jayashankar	SEAG 63336 3058		
7590 04/20/2004			EXAMINER		
Robert P. Lenart			LE, THAO P		
Pietragallo, Bosick & Gordon				DARED MARKET	
One Oxford Centre, 38th Floor			ART UNIT	PAPER NUMBER	
301 Grant Street			2818		
Pittsburgh, PA 15219			DATE MAILED: 04/20/2004		

DATE MAILED: 04/20/2004

Please find below and/or attached an Office communication concerning this application or proceeding.

	Applicati	on No.	Applicant(s)					
Office Action Summary	10/603,3		JAYASHANKAR E	I AL.				
Office Action Summary	Examine		Art Unit					
	Thao P L		2818					
The MAILING DATE of this commun Period for Reply	ncation appears on th	e cover sneet with the c	orrespondence add	iress				
A SHORTENED STATUTORY PERIOD F THE MAILING DATE OF THIS COMMUN - Extensions of time may be available under the provision: after SIX (6) MONTHS from the mailing date of this com - If the period for reply specified above is less than thirty (1) - If NO period for reply is specified above, the maximum s - Failure to reply within the set or extended period for repl - Any reply received by the Office later than three months earned patent term adjustment. See 37 CFR 1.704(b). Status	ICATION. s of 37 CFR 1.136(a). In no exmunication. 30) days, a reply within the statatutory period will apply and word will by statute. cause the apply and word will.	vent, however, may a reply be tim tutory minimum of thirty (30) day vill expire SIX (6) MONTHS from olication to become ABANDONE	nely filed s will be considered timely the mailing date of this co D (35 U.S.C. § 133).	: mmunication.				
1) Responsive to communication(s) fil	ed on <u>25 June 2003</u> .							
2a) This action is FINAL .	2b)□ This action is n	on-final.						
3) Since this application is in condition for allowance except for formal matters, prosecution as to the merits is closed in accordance with the practice under <i>Ex parte Quayle</i> , 1935 C.D. 11, 453 O.G. 213.								
Disposition of Claims								
4) Claim(s) 1-27 is/are pending in the application. 4a) Of the above claim(s) is/are withdrawn from consideration. 5) Claim(s) is/are allowed. 6) Claim(s) is/are rejected. 7) Claim(s) is/are objected to. 8) Claim(s) 1-27 are subject to restriction and/or election requirement.								
Application Papers								
9) The specification is objected to by the specification is objected to by the specific transfer of tra	ection to the drawing(s) g the correction is requi	be held in abeyance. Seired if the drawing(s) is ob	e 37 CFR 1.85(a). ojected to. See 37 CF					
Priority under 35 U.S.C. §§ 119 and 120								
12)								
Attachment(s) 1) Notice of References Cited (PTO-892) 2) Notice of Draftsperson's Patent Drawing Review (3) Information Disclosure Statement(s) (PTO-1449)		4) Interview Summary 5) Notice of Informal 6						

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DETAILED ACTION

Election/Restrictions

1. Restriction to one of the following inventions is required under 35 U.S.C. 121:

I. Claims 1-14: draw to a method of chemical mechanical polishing a wafer that is classified in class 438, subclass 459.

- II. Claims 15-27: draw a wafer for use in manufacturing a magnetic recording head that is classified in class 257, subclass 421.
- 2. Inventions I and II above are related as method and device. The inventions are distinct if it can be shown that either:
- a) the product (II) as claimed can be made by another and materially different process. (MPEP 806.05(e)), or
- b) the method (I) as claimed can be practiced by another materially different product or by hand.

For instance, unpatentability of the group II invention would not necessarily imply unpatentability of the group I invention, since the device of the group II invention could be made by other processes materially different from those of the group I invention.

For example, the wafer formed in group II invention doesn't include the removal of material from wafer using a chemical mechanical polishing process nor irradiating light onto a surface of the wafer as required in the method of group I invention.

Since these two groups are classified in two distinct classes, it is required serious burden searches.

- 3. Because the inventions are distinct from the reasons given above and have acquired a separate status in the art as shown by their different classification, restriction for examination purposes as indicated is proper.
- Applicant is reminded that upon the cancellation of claims to a non-elected invention, the inventorship must be amended in compliance with 37 CFR 1.48(b) if one or more of the currently named inventors is no longer an inventor of at least one claim remaining in the application. Any amendment of the inventorship must be accompanied by a petition under 37 CFR 1.48(b) and by the fee required under 37 CFR 1.17(I).
- 5. A shortened statutory period for response to this action is set to expired 1 (one) months and 0 (zero) day from the date of this letter. Failure to respond within the period for response will cause the application to become abandoned (see 710.02 (b)).

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Thao P Le whose telephone number is 571-272-1785. The examiner can normally be reached on M-T (8:00-6:30).

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, David Nelms can be reached on 571-272-1787. The fax phone number for the organization where this application or proceeding is assigned is (703) 872-9306.

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Any inquiry of a general nature or relating to the status of this application or proceeding should be directed to the receptionist whose telephone number is 703-308-1956.

Thao Phuong Le